PSI-CAMEA - MAGNET OPTICS

MAGNET OPTICS

Jakob Lass



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1 Plan

1.1 Notes from meeting 13/03/18

Focusig, in principle for eliptical → simulated by straight for MA15 (test case for MA9)

- 2.3 degrees opening angle 4AA
- m=6
- sample size: 5x5mm
- 30cm at the magnet. Compare with only sample position (should be 5x5mm)
- Inner dimention is 7mm (focus for 5 mm on sample position)
- limits for outer diameter
- Reference sample to look at resolution
- ? Maybe Union
- Build up a 'complete' back-end

1.2 Magnet limitations

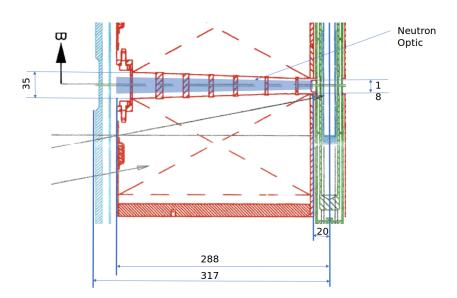


Figure 1: Sketch of optic dimensions due to magnet limitations.

- MagnetOpticsOpening = 0.030,
- MagnetOpticsEnd = 0.007,
- MagnetOpticsLenght=0.268,
- MagnetOpticsM = 6,
- MagnetOpticsWidth = 0.2,

1.3 Original setup

Setup consists of:

```
COMPONENT MonoFLat = Monochromator_curved(
    zwidth = 0.05, yheight = 0.025, gap = 0.0005, NH = 3,
    NV = 5, DM=3.355, mosaich = 37, mosaicv = 37, r0 = 1,
     RV = RV_{mono}, RH = RH_{mono}
  AT (0, 0, 1.6) RELATIVE SlitGuideEnd
  ROTATED (0, thetaA1,0) RELATIVE SlitGuideEnd
COMPONENT A2 = Arm()
  AT (0, 0, 1.6) RELATIVE SlitGuideEnd
 ROTATED (0, thetaA2, 0) RELATIVE SlitGuideEnd
COMPONENT SlitMagnetStart = Slit(
    xwidth = MagnetSlitWidth , yheight = MagnetSlitHeight)
  AT (0, 0, 1.3) RELATIVE A2
COMPONENT PsdMagnet = PSD_monitor(
    nx = 100, ny = 100, filename = "PSD_Magnet_opening.dat", xwidth = 0.2,
    yheight = 0.2
  AT (0, 0, 1.3) RELATIVE A2
COMPONENT DivMon_Magnet = Divergence_monitor(
    nh = 100, nv = 100, filename = "Div_Magnet_opening.dat",
    xwidth = 0.2, yheight = 0.2, maxdiv_h = 6, maxdiv_v = 6.5)
   AT (0, 0, 0) RELATIVE PREVIOUS
COMPONENT PsdSampleBeamProfile = PSD_monitor(
    nx = 100, ny = 100, filename = "PsdSampleBeamProfile.dat", xwidth = 0.2,
    yheight = 0.2
  AT (0, 0, 1.6) RELATIVE A2
COMPONENT DivMonSampleBeamProfile = Divergence_monitor(
    nh = 100, nv = 100, filename = "DivMonSampleBeamProfile.dat",
    xwidth = 0.2, yheight = 0.2, maxdiv_h = 6, maxdiv_v = 6.5)
   AT (0, 0, 0) RELATIVE PREVIOUS
COMPONENT PsdSampleSimulator = PSD_monitor(
    nx = 100, ny = 100, filename = "PsdSampleSimulator.dat", xwidth = 0.005,
    yheight = 0.005
  AT (0, 0, 0) RELATIVE PREVIOUS
COMPONENT DivMonSampleSimulator = Divergence_monitor(
    nh = 100, nv = 100, filename = "DivMonSampleSimulator.dat",
```

<code>xwidth = 0.005</code>, <code>yheight = 0.005</code>, <code>maxdiv_h = 6</code>, <code>maxdiv_v = 6.5</code>) AT (0, 0, 0) RELATIVE PREVIOUS



Figure 2: Flat monochromator with slits and without optics.

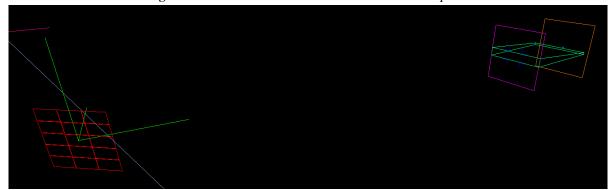


Figure 3: Flat monochromator with slits and with optics.

1.4 Comparison

	Flat Mono WO	VCurved Mono WO	Flat Mono W	VCurved Mono W
Intensities	177282	432272	204688	591671
Flat Mono WO	1	2.44	1.15	3.34
VCurved Mono WO	_	1	0.47	1.37
Flat Mono W	_	_	1	2.89
VCurved Mono W	_	_	_	1

Table 1: Comparison between vertically focused/unfocused and with/without optics

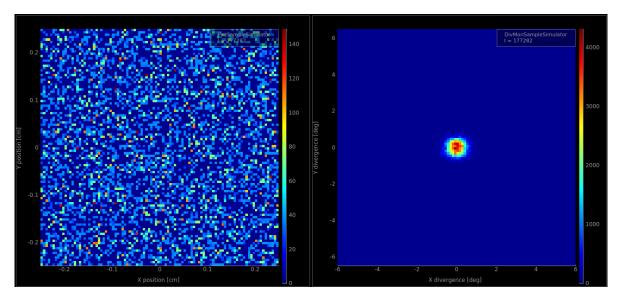


Figure 4: No optics flat.

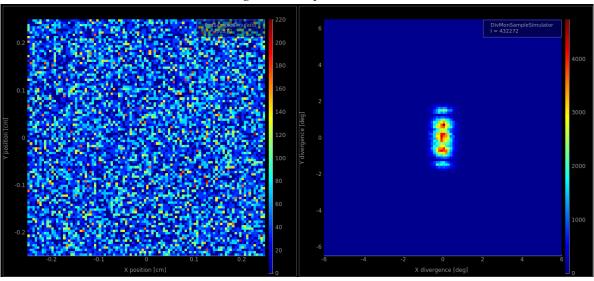


Figure 5: No optics curved vertically.

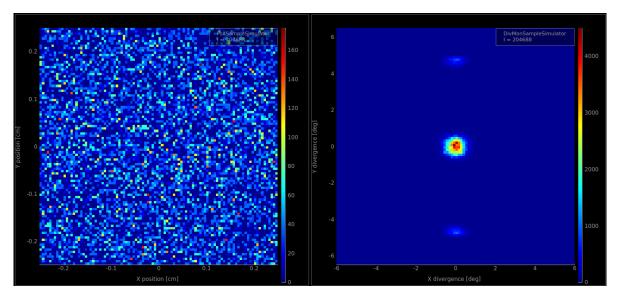


Figure 6: Flat optics flat.

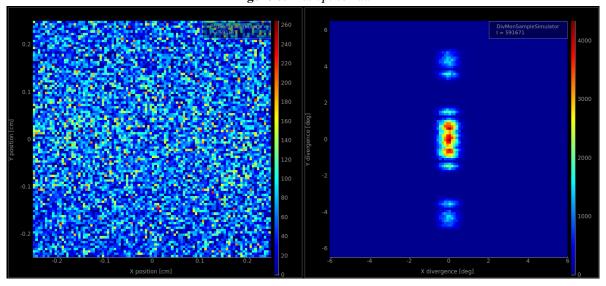


Figure 7: Flat optics curved vertically.

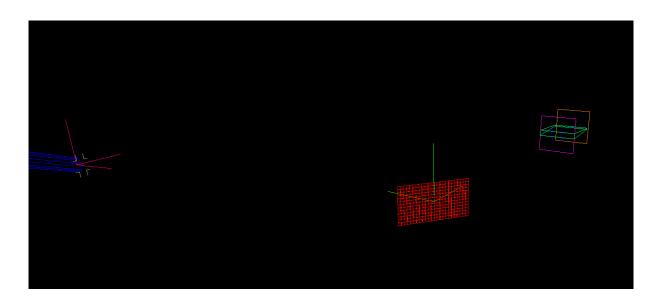
1.5 Future Monochromator

The future monochromator might change the efficiency of adding the optics. The monochromator is given as

```
COMPONENT Mono = Monochromator_curved(
   zwidth = 0.01, yheight = 0.01, gap = 0.0005, NH = 24,
   NV = 13, DM=3.355, mosaich = 37, mosaicv = 37, r0 = 1,
   RV = RV_mono, RH = RH_mono)
AT (0, 0, 1.6) RELATIVE SlitGuideEnd
ROTATED (0, thetaA1,0) RELATIVE SlitGuideEnd
```

	Flat Mono WO	Curved Mono WO	Flat Mono W	VCurved Mono W
Intensities	160212	598328	197003	833920
Flat Mono WO	1	3.73	1.23	5.21
VCurved Mono WO	_	1	0.33	1.39
Flat Mono W	_	_	1	4.23
VCurved Mono W	_	_	_	1

 Table 2: Comparison between double focused/unfocused and with/without optics with the future monochromator.



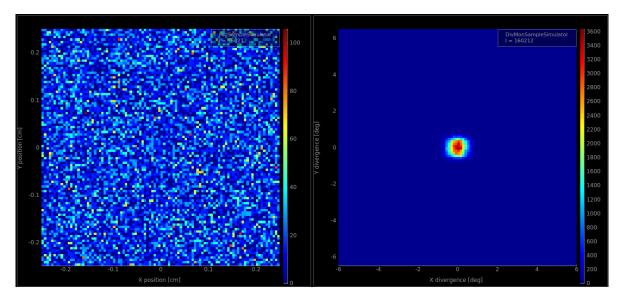


Figure 8: No optics flat with new monochromator.

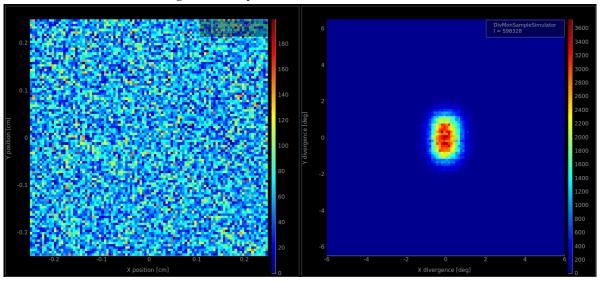


Figure 9: No optics double focusing with new monochromator.

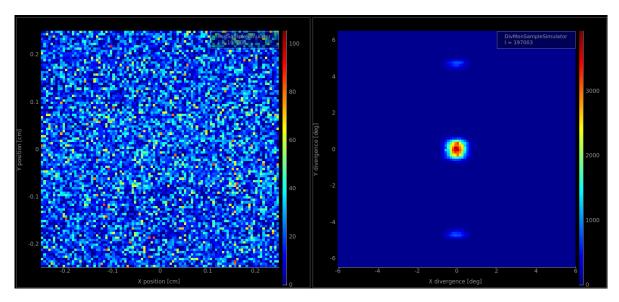


Figure 10: Flat optics flat with the future monochromator.

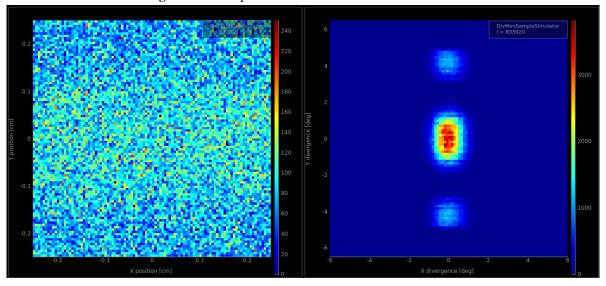


Figure 11: Flat optics double focusing with the future monochromator.

1.6 Next steps

Possible next steps

- Eliptical optics
- Optimzation of optic opening
- Full simulation

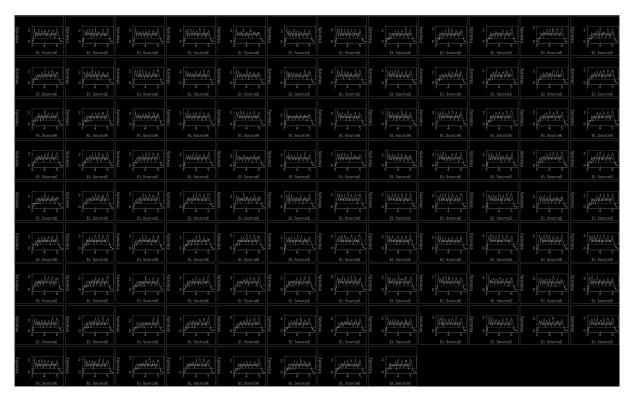


Figure 12: Energy scan, flat monochromator, without optics, VanSample with radius=0.005m and yheight=0.01m

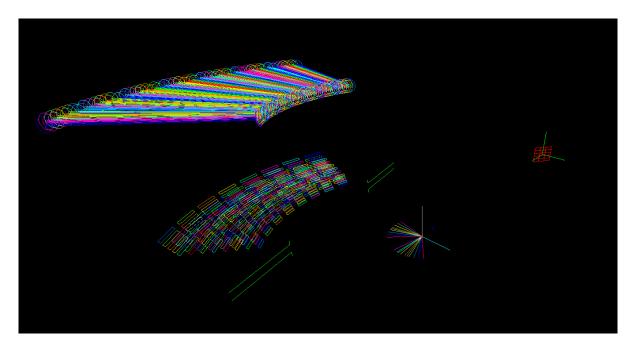


Figure 13: Instrument view of energy scan simulation with two slits.

1.7 Folder overview

1.7.1 Old Monochromator

Flat monochromator without optics:

• OriginalFlat

Vertically curved monochromator without optics:

• OriginalCurved

Flat monochromator with flat optics:

• FlatOpticsFlat

Vertically curved monochromator with flat optics:

• FlatOpticsCurved

1.7.2 New Monochromator

Flat monochromator without optics:

• FutureMonochromator/Flat

Double focusing monochromator without optics:

• FutureMonochromator/DoubleCurved

Flat monochromator with flat optics:

• FutureMonochromator/FlatWithOptics

Doble focusing monochromator with flat optics:

• FutureMonochromator/CurvedWithOptics